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# Electromagnetic embossing and forming of optical microstructures

I2FG

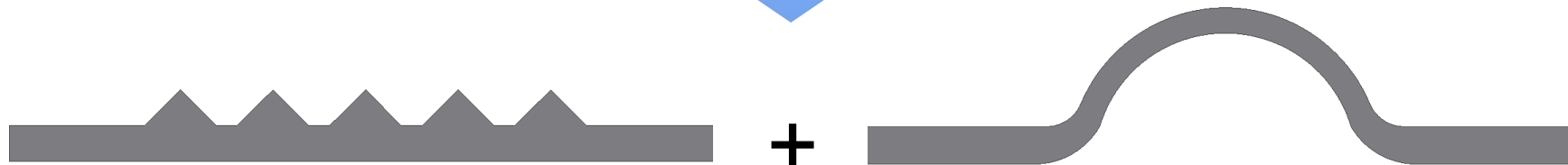
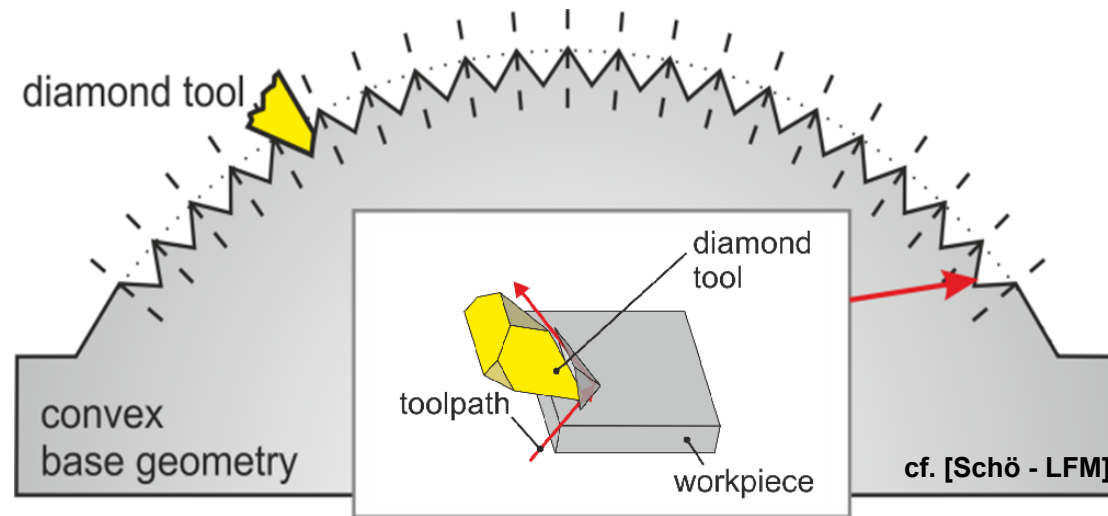
workshop on impulse metalworking

2<sup>nd</sup> December 2016 - Nantes

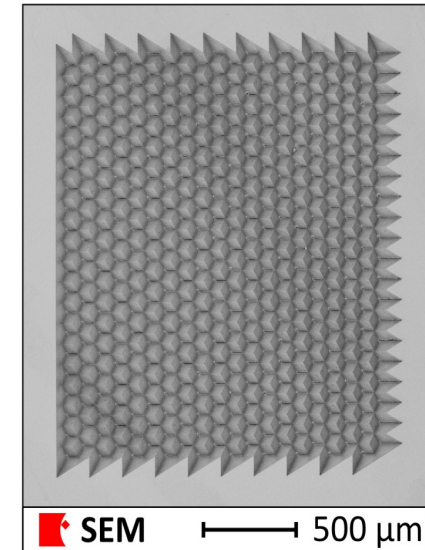
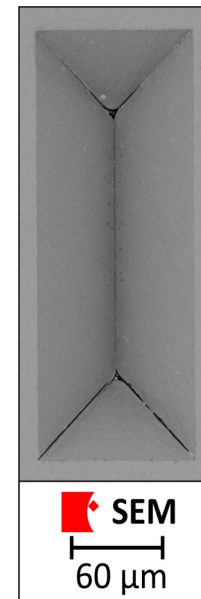
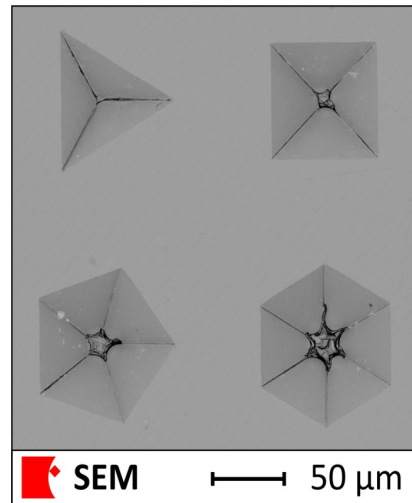
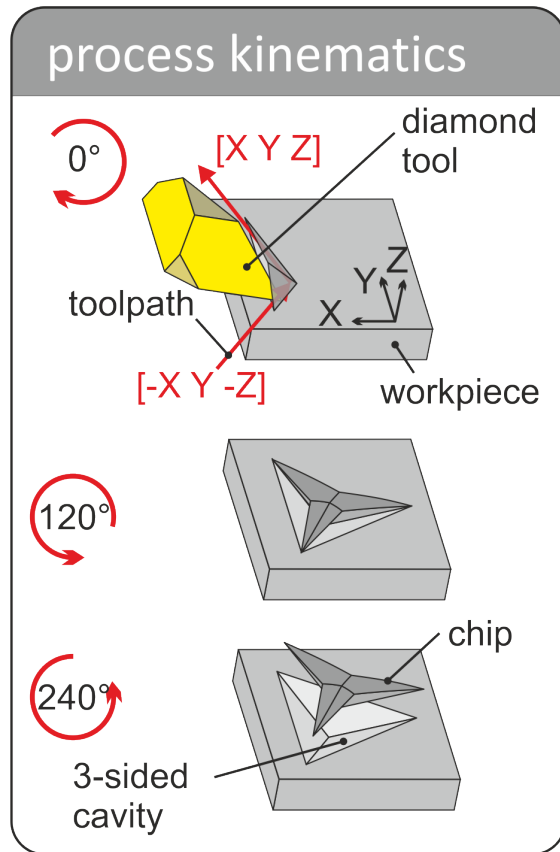
L. Langstädtler – bime – University of Bremen



# Motivation

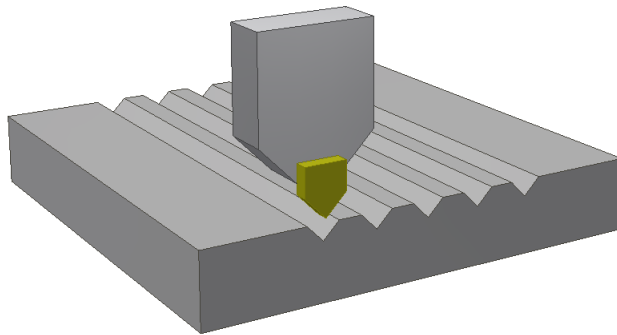


# Diamond micro chiseling (DMC)

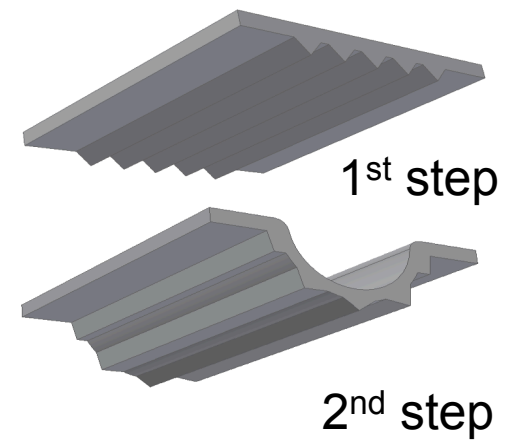
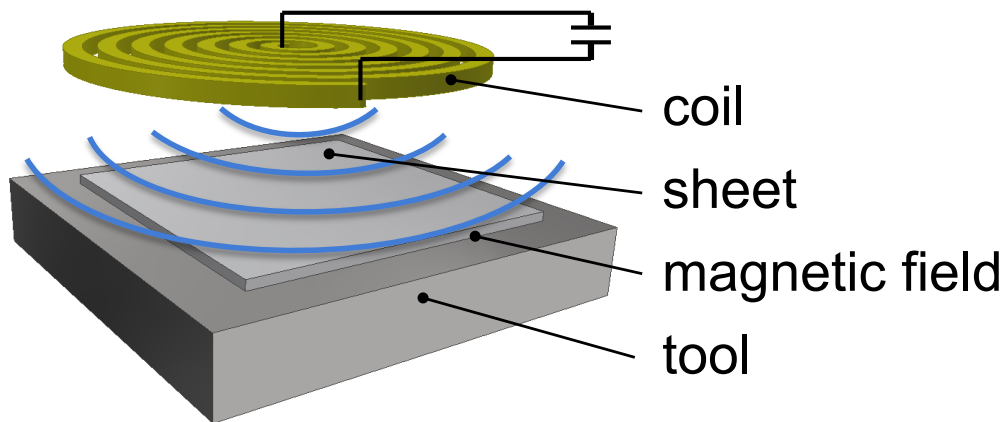
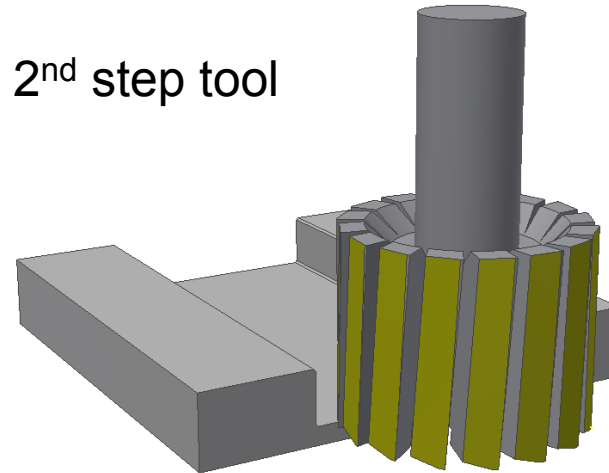


→ conventional process

1<sup>st</sup> step tool

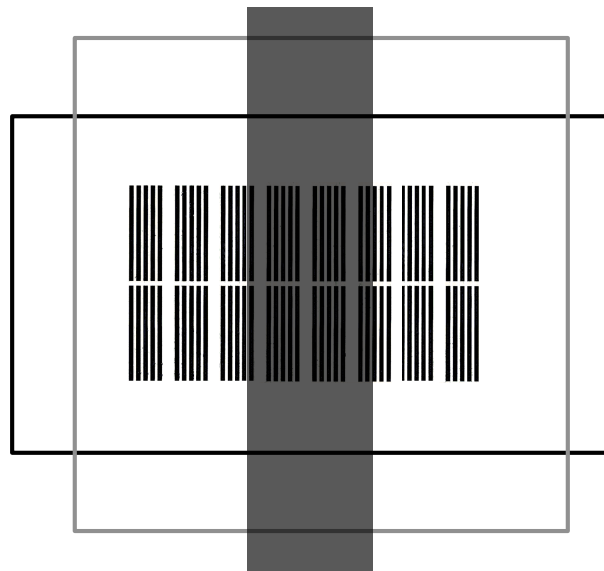
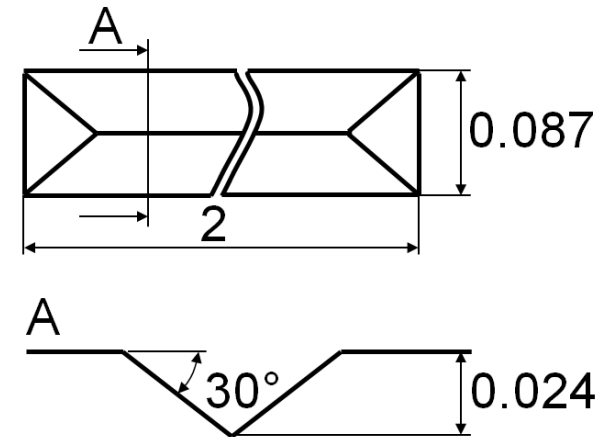
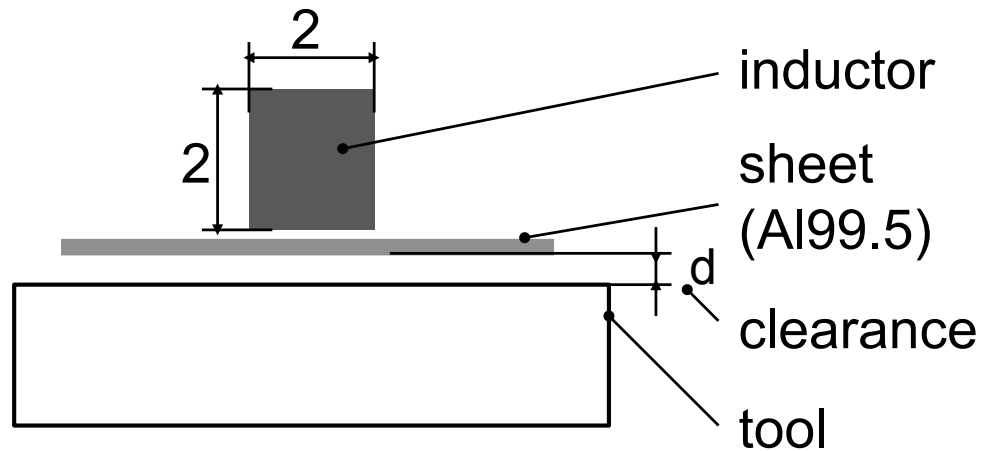


2<sup>nd</sup> step tool



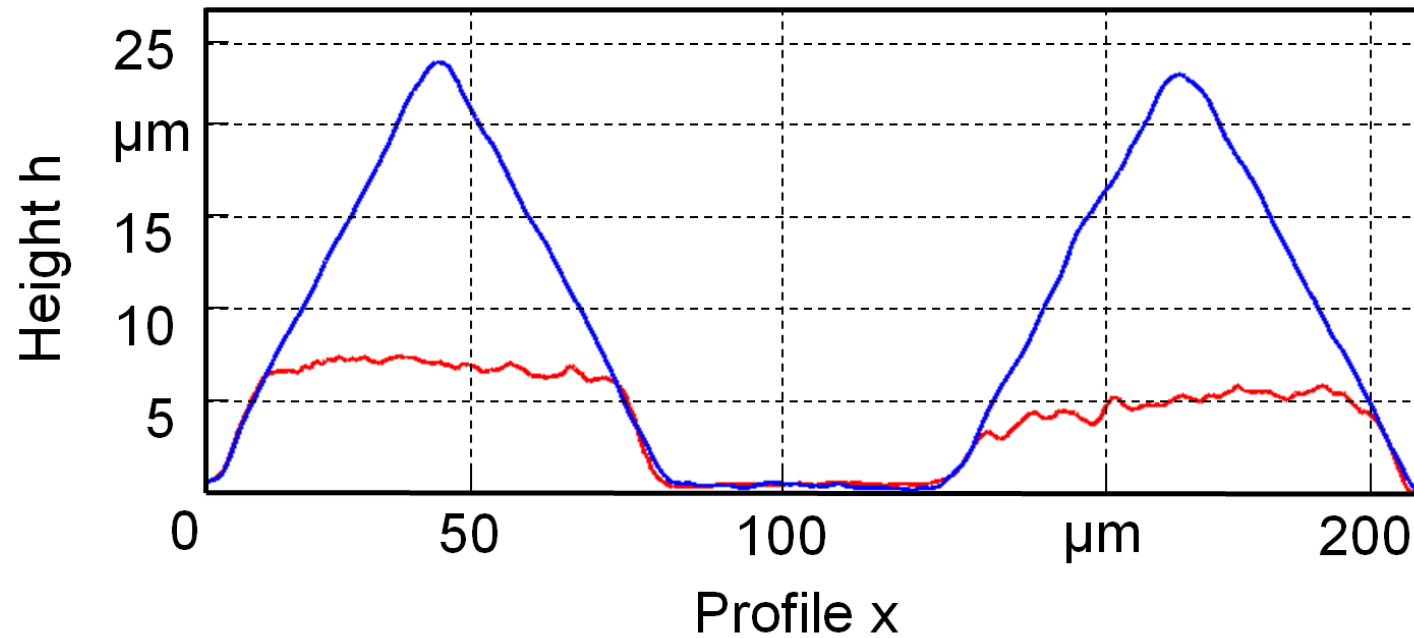


# Experimental set up

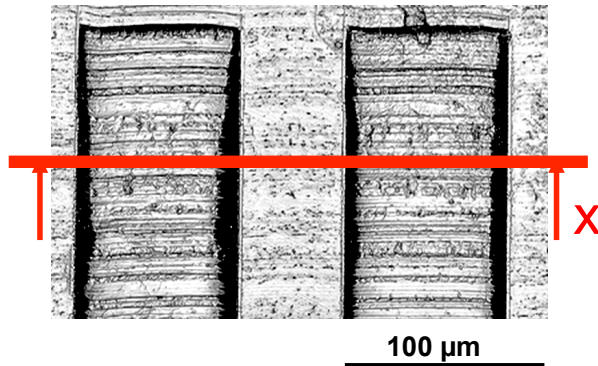


Energy $E_c$	1.8 kJ
current $I_{max}$	70 kA
frequency $f_0$	22 kHz
workpiece velocity	200 m/s
impact pressure	500 MPa

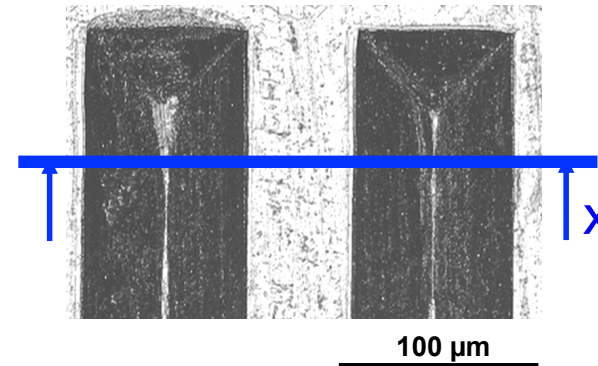
# Structural deformation behavior



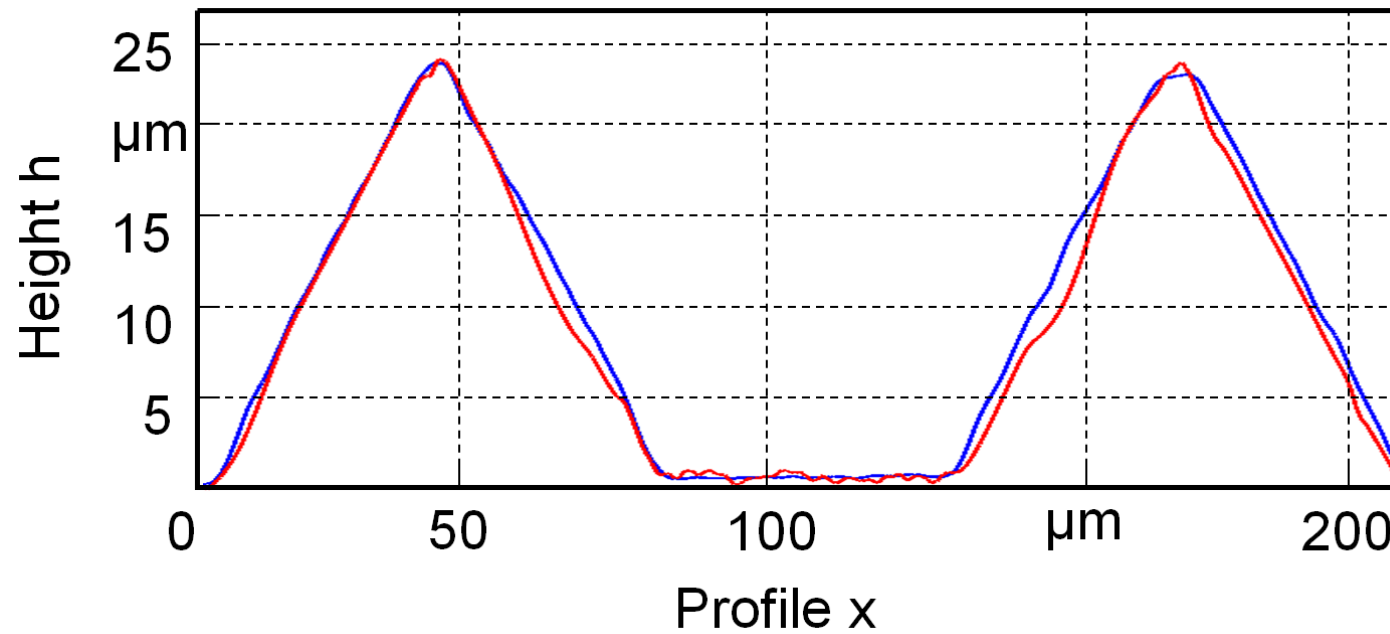
$s_0 = 50 \mu\text{m}$



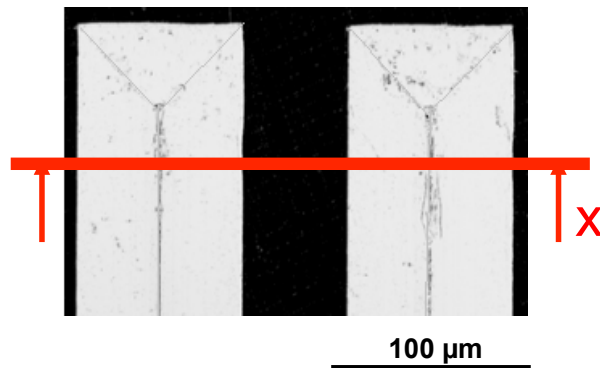
$s_0 = 300 \mu\text{m}$



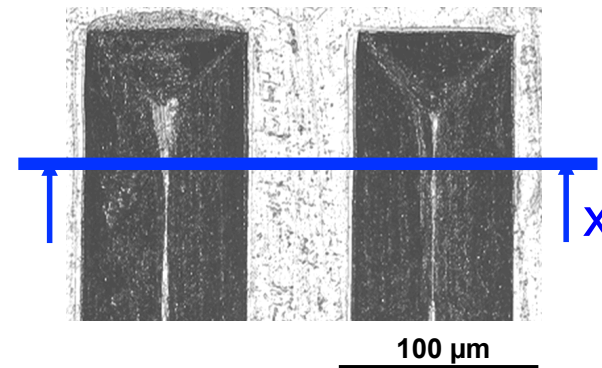
# Quality of embossed structure



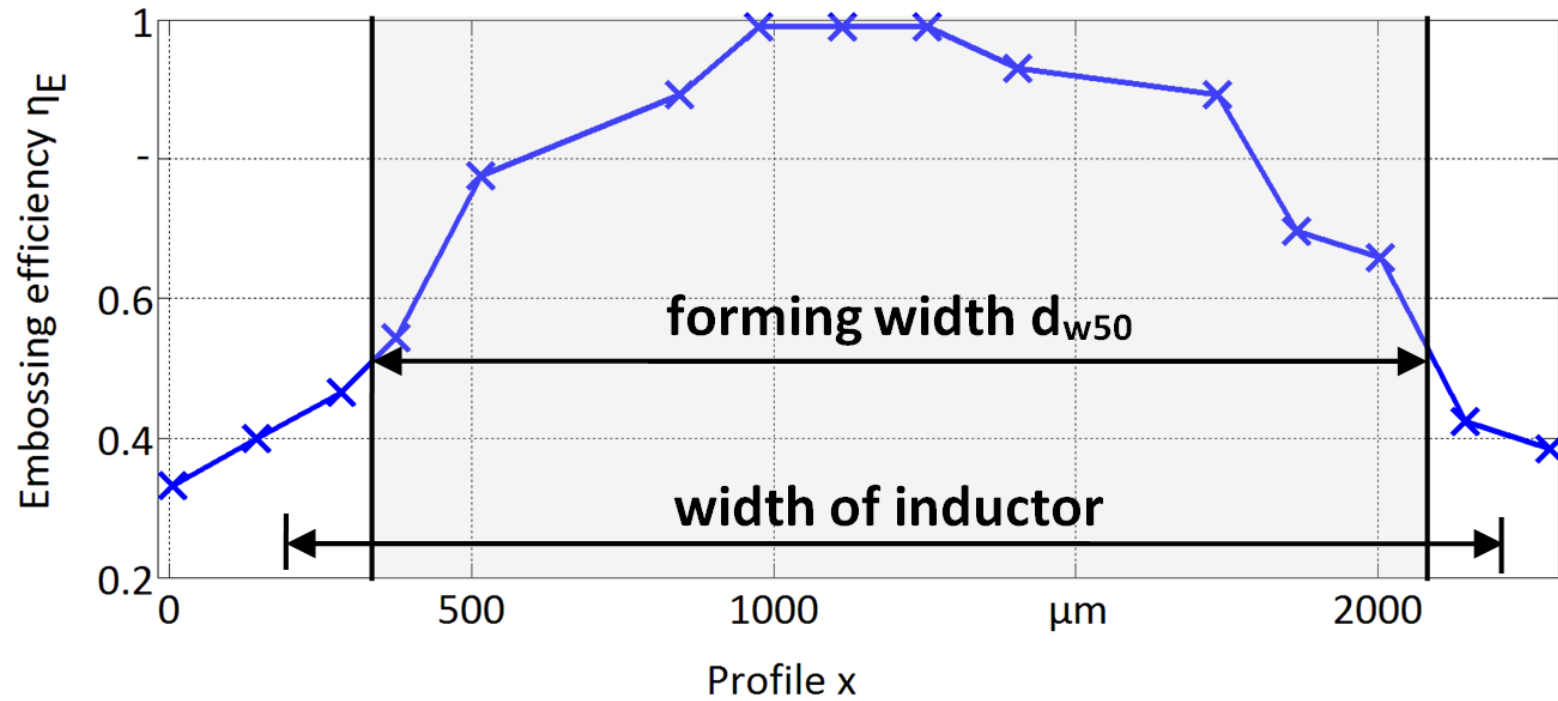
tool



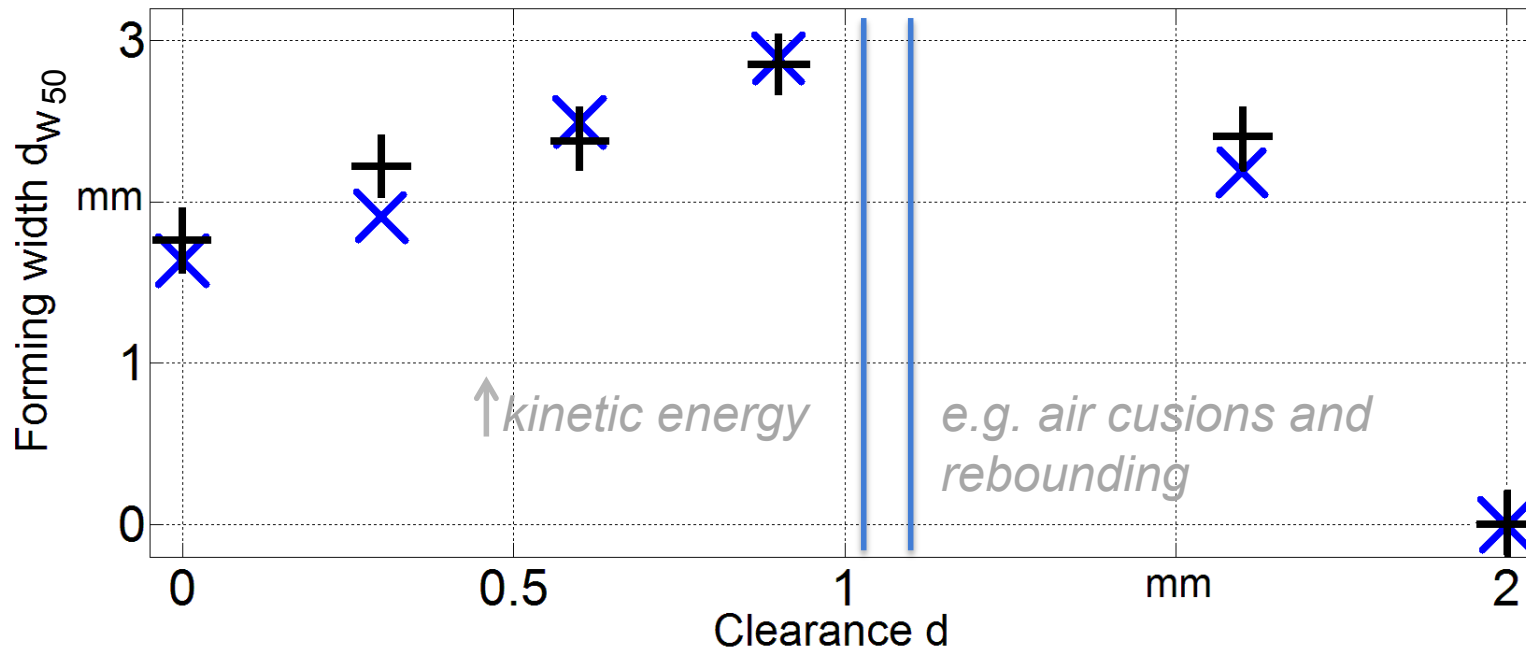
sheet ( $s_0 = 300 \mu\text{m}$ )



# Embossing efficiency



# Lateral deformation behavior



$\text{+}$   $s_0 = 50 \mu\text{m} + \text{driver}$

$\text{x}$   $s_0 = 300 \mu\text{m}$

# Quality of embossed surface

probe initial surface

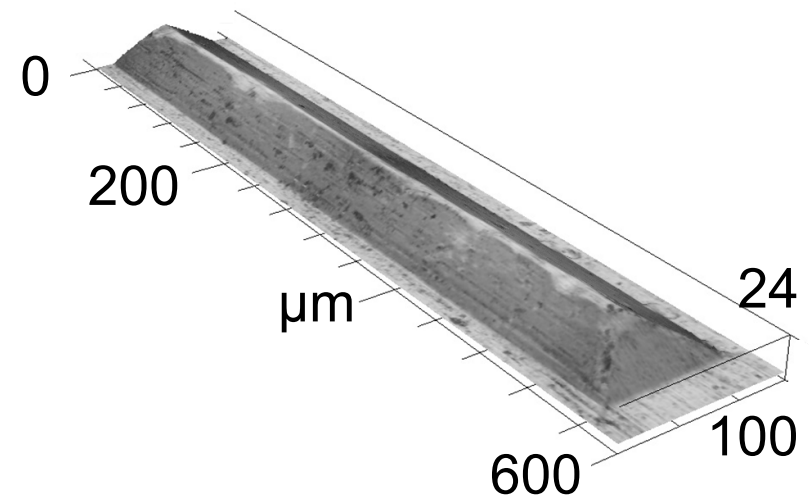
**Sa = 1000 nm**

tool surface

**Sa = 20 nm**

probe embossed surface

**Sa = 44 nm**



**probe**



50 µm

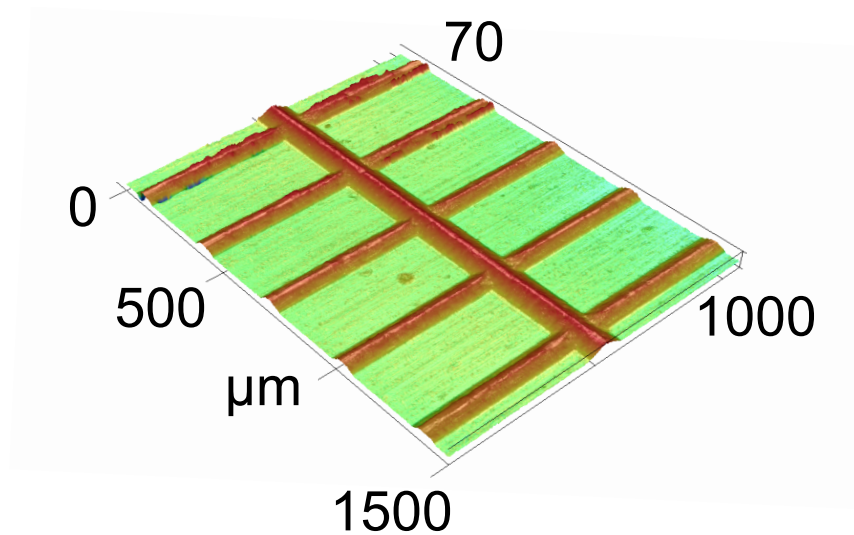
$s_0 = 0.3 \text{ mm}$

$d = 0.9 \text{ mm}$

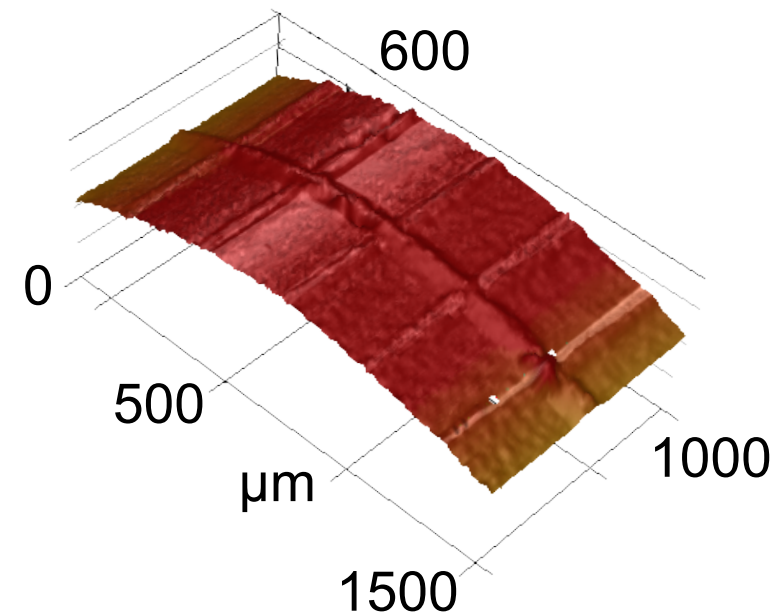
$E_C = 1.8 \text{ kJ}$

# Sequenced forming

1<sup>st</sup> step  
embossing  
 $d = 0.9 \text{ mm}$ ;  $E_C = 1.8 \text{ kJ}$



2<sup>nd</sup> step  
free forming  
 $d = 0 \text{ mm}$ ;  $E_C = 0.6 \text{ J}$



*microstructure can be inside or outside of the freeformed macrogeometry due to the application of the formed part*



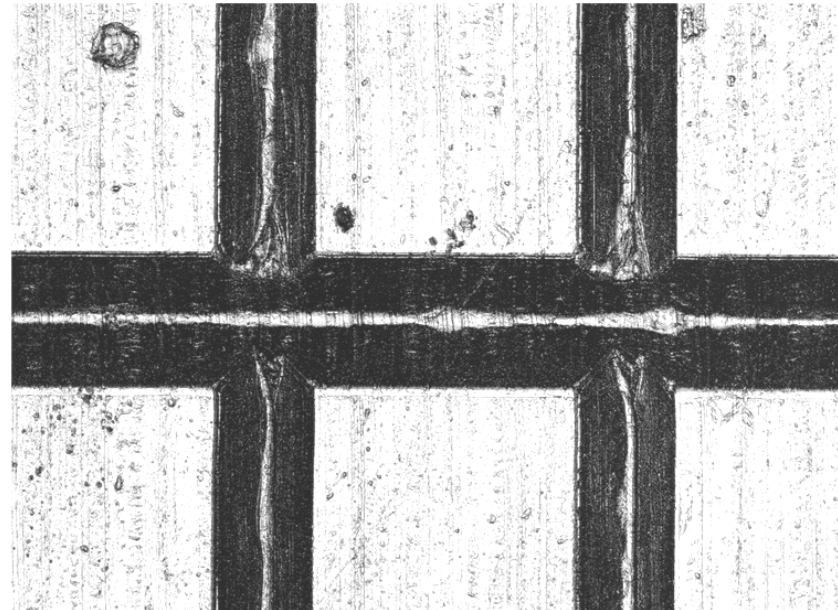
# Cross structure – 1<sup>st</sup> step

tool



100  $\mu\text{m}$

sheet

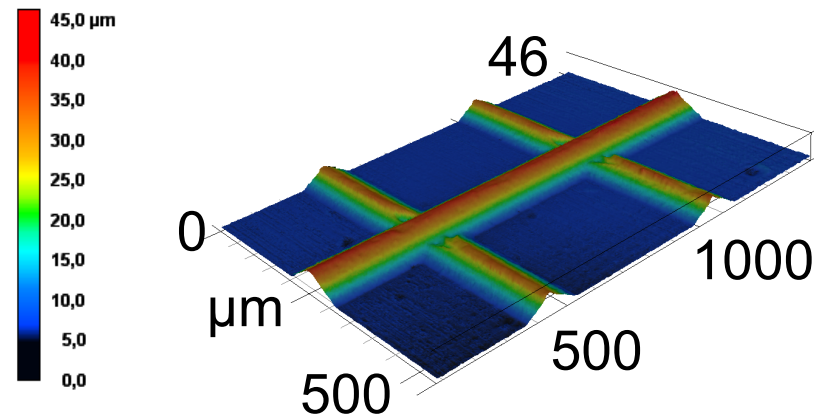


100  $\mu\text{m}$

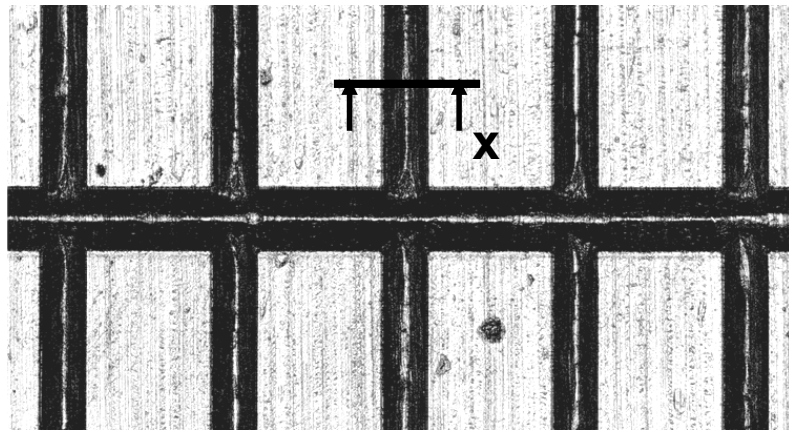
$$s_0 = 0.05 \text{ mm} + \text{driver}$$

$$d = 0.9 \text{ mm}$$

$$E_C = 1.8 \text{ kJ}$$



# Cross structure – 2<sup>nd</sup> step

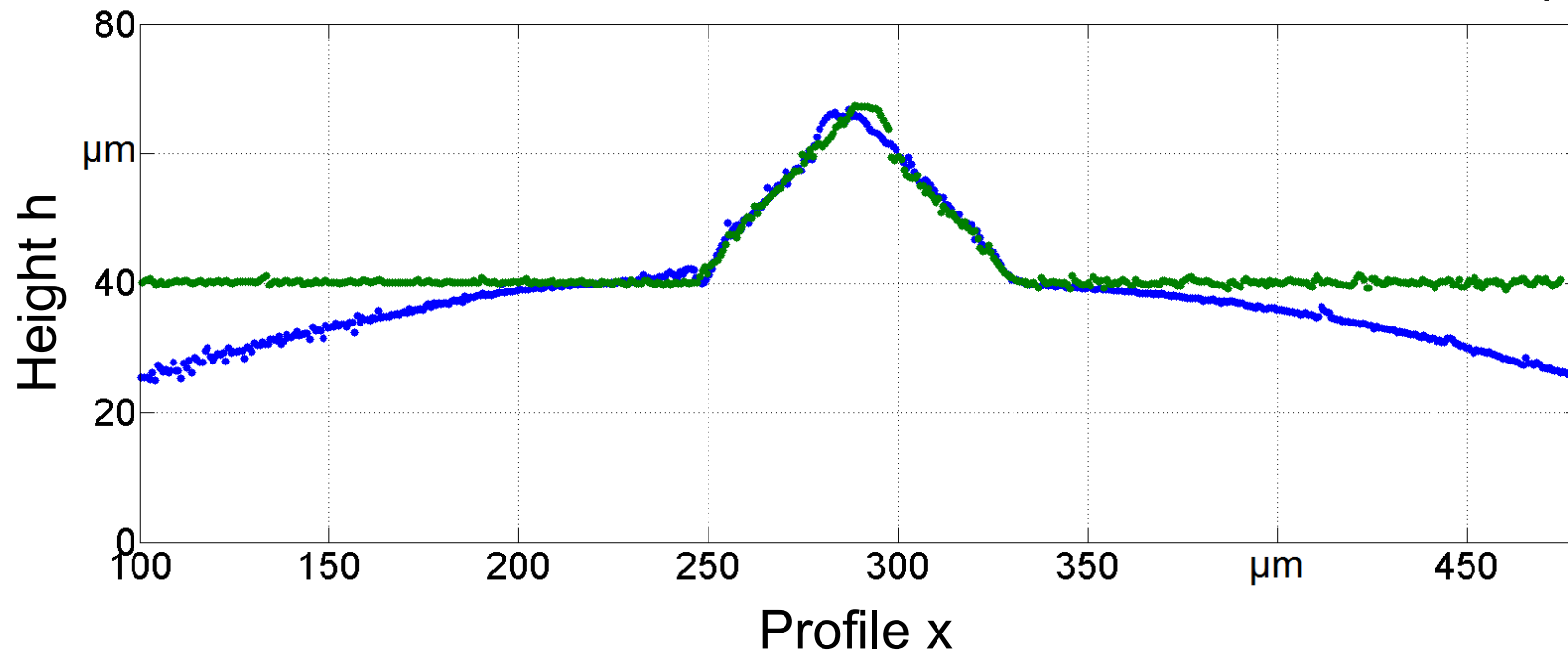


1<sup>st</sup> step probe

200  $\mu\text{m}$

microstructure deformation:  
with 20 % strain in the makro  
geometry no influence on width

— 1<sup>st</sup> step  
— 2<sup>nd</sup> step

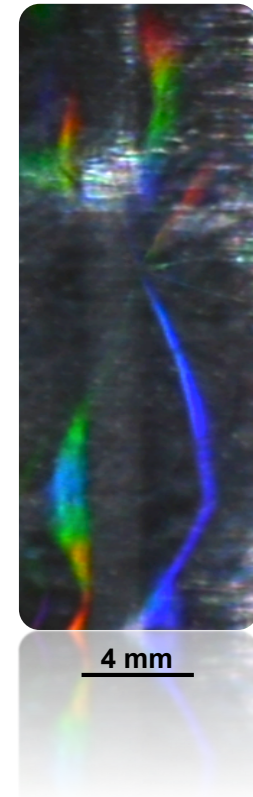
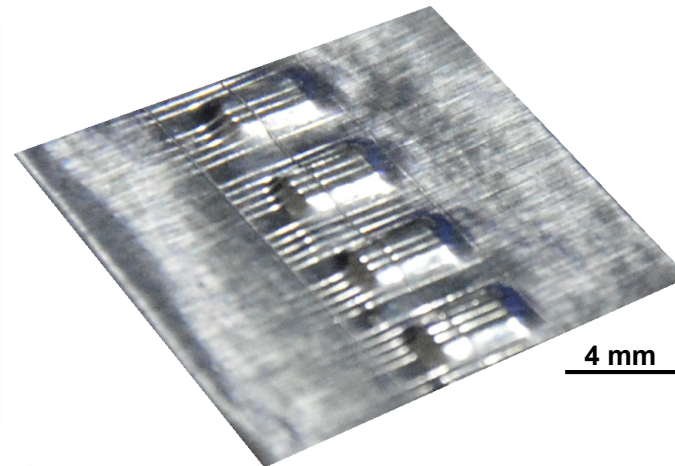


- replication of microstructures
- replication of surface quality with near optical finish
- embossing thin micro metal sheets
- free forming of structured sheets
- complex optical geometries realizable
- shorter manufacturing times
- lower invest (tools)



# Future work

- 1<sup>st</sup> step
  - embossing of more complex micro structures
  - embossing of optical diffractive structures
- 2<sup>nd</sup> step
  - controlling macro geometry and shape by adapted micro structures





# Contact

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## *Thanks to...*

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